

SEARCHED			
Class	Sub.	Date	Exmr.
438	680 694 478-79 906 913 728	10/29/03	g
414	221, 935 118		
	715, 900		
438 & 118	1122700	5/26/03	g

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	Date	Exmr.	
WAFER TRANSFER CHAMBER	10/29/03	g	
SUPPLY/EXHAUST INLET GAS			
WAFER PROCESSING VACUUM PUMP			
ADD CONTINUOUS INLET GAS	5/26/03	g	
TRANSLATED ORAL + WRITTEN	5/27/03	g	

INTERFERENCE SEARCHED			
Class	Sub.	Date	Exmr.

BEST AVAILABLE COPY